China

CE, Rohs

A63.7004

5~20 Days

5000 pcs/ Month

CNOEC, OPTO-EDU

FOB \$1~1000, Depend on Order Quantity

Carton Packing, For Export Transportation

OPTO-EDU A63.7004 Single-Crystal Filament Scanning Electron Microscope SE BSE 360000x 3nm@20KV

Basic Information

- Place of Origin:
- Brand Name:
- Certification:
- Model Number:
- Minimum Order Quantity: 1 pc
- Price:

Our Product Introduction

- Packaging Details:
- Delivery Time:
- Payment Terms: T/T, West Union, Paypal
- Supply Ability:



0

Product Specification

 Resolution: 	3nm@20KV
 Magnification: 	360000x
Electron Gun:	LaB6
 Voltage: 	3-20KV
Detector:	BSE+SE

Navigation CCD: CCD+Cabin Camera

Magnification 360000x Resolution 3nm@20KV With Detector SE+BSE+CCD, Optional EDS Standard X/Y Motorized Working Stage, Optional 3 Axes X/Y/Z, 5 Axes X/Y/Z/R/T Single Crystal LaB6 Filament Catridge Voltage 20kV, Life Time >1500 Hours High Vaccum System With Mechanical Rotary Pump To Get Vaccum In 30s One Key Auto Focus, Auto Brightness & Contrast Adjust, No Need Shock Absorbing Table



F-1501 Wanda Plaza, No.18 Shijingshan Road, Beijing 100043, China Tel:+8610 88696020 Fax:+8610 88696085

OPTO-EDU

A63.7004

Single-Crystal Filament Scanning Electron Microscope, SE+BSE, 360000x, 3nm@20KV





A63.7004 Desktop Scanning Electron Microscopes (SEM), upgrade the gun from tungsten to LaB6, incorporate numerous innovative technologies, offering not only excellent imaging performance but also portability, catering to a wide range of application needs. Both domestically and internationally, the ZEM series, with its high-end positioning and diverse models, has achieved advanced standards in imaging clarity, user-friendliness, and system integration.

A63.7004 is renowned for its high level of integration and flexible configuration options. The user interface is simple, easy to learn, and operate, allowing even non-expert users to quickly become proficient. The accompanying software supports the entire workflow, from sample preparation, parameter adjustment, to image analysis, providing an integrated and efficient solution. **A63.7004** has demonstrated strong analytical capabilities across multiple fields such as new materials, new energy, biomedicine, and semiconductors, assisting researchers in exploring the mysteries of the microscopic world. Due to its excellent cost-performance ratio, the ZEM series has become a preferred choice for many universities, research institutions, and enterprises seeking a desktop scanning electron microscope.

The A63.7004 benchtop SEM utilizes a wider range of accelerating voltages, 1Kv steps, and a maximum magnification of 360,000x with a resolution of up to 5nm The tabletop deceleration mode allows real-time observation of low-conductivity products without the need for gold spraying. The extra-large sample compartment can be integrated with a wide range of in-situ expansion platforms to meet different experimental and inspection needs.



A63.7004 Features

Working Conditions:

Environmental requirements: small size, the whole machine can be placed on an ordinary laboratory table, no need to be equipped with an additional shock absorbing table.

1. Power supply 220V, 50Hz, 1KW

2. Temperature: Operating ambient temperature: 15°C-30°C

3.Humidity: <80%RH



▲ Vacuum Separation Technology: Utilizes a unique vacuum design where the electron gun and sample chamber have separate vacuums, allowing for sample change in less than 1 minute.

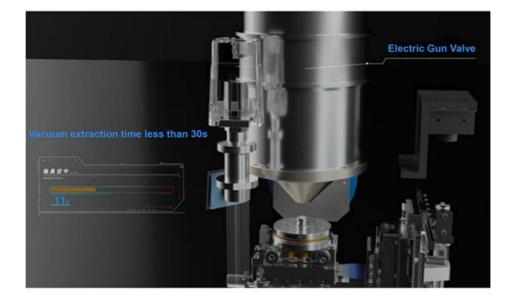
▲ Extra-Large Sample Chamber: Provides a larger sample storage space for convenient user operation.

▲ Ultra-High Resolution: Achieves a maximum magnification of 360,000 times with a resolution of 3nm at 20kV.

▲ Standard Equipped Deceleration Mode: Allows for the observation of weakly conductive samples without gold sputtering.

▲ In-Chamber Camera: The sample chamber is equipped with a high-definition camera for real-time monitoring of sample changes during in-situ experiments.

OPTO-EDU



A63.7004 Specification



Main Specification:

- 1. Acceleration voltage: 3-20kV, continuously adjustable.
- 2. Electron gun type: pre-aligned single crystal LaB6 filament, life time 1500 hours, highly integrated two-stage
- gun lens, no need to manually adjust the diaphragm of the objective lens.
- 3. Magnification ≥360000X
- 4. Resolution:≤3nm@20KV
- 5. Detector: secondary electron detector (SE), quadruple backscatter detector (BSE),
- 6. Stage: 2 Axis XY motorized stage, moving 60x55mm
- 7. Maximum sample size: 100*78*68.5mm while XY axes move freely
- 8. Sample change and high vacuum pumping time≤ 90s.
- 9. High vacuum system: mechanical pump, turbo molecular pump, ion pump, the vacuum in sample chamber
- ≥4x10-2Pa, fully automatic control;
- 10. Video mode \geq 512x512 pixels, no need for small window scanning.
- 11. Quick scan mode: imaging time≤3s, 512x512 pixels.
- 12. Slow scan mode: imaging time≤40s, 2048x2048 pixels.
- 13. Image File: BMP, TIFF, JPEG, PNG.
- 14. One-key automatic adjustment of brightness and contrast, auto-focus, large image stitching
- 15. Navigation function: optical camera navigation and cabin camera.
- 16. Image measurement function: distance, angle, etc.
- 17. Including computer & software, mouse control.
- 18. Optional:
- --Tungsten filament (20pcs/box)

--EDS

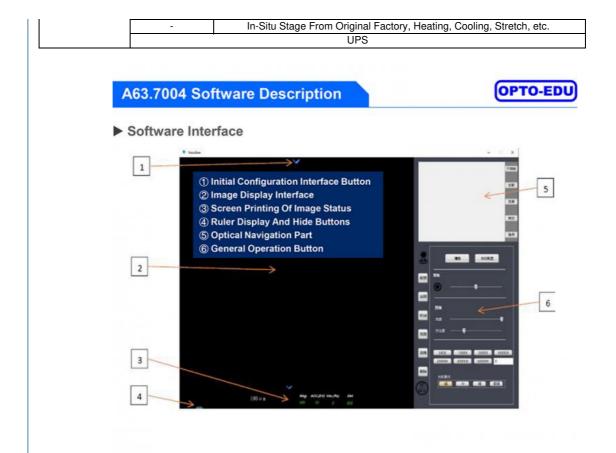
- --3 Axis Motorized Stage XYZ
- --3 Axis Motorized Stage XYT
- --5 Axis Motorized Stage XYZRT
- --Low vacuum (1-60Pa)
- --In-Situ stage from original factory, heating, cooling, stretch, etc.
- --Deceleration Mode, 1-10KV, can observe non-conductor or poor conductivity samples without gold spraying,

only for BSE mode

- --Shock-absorbing Platform (recommend for A63.7004)
- 19. Microscope size 650*370*642mm, mechanical pump size 340*160*140mm

1225	RUDH	

Model	A63.7001	A63.7002	A63.7003	A63.7004	A63.7005
Resolution	10nm@15KV	6nm@18KV	4nm@20KV	3nm@20KV	2.5nm@15KV
Magnification	150000x	200000x	360000x	360000x	1000000x
Electron Gun	Tungsten	Tungsten	Tungsten	LaB6	Schotty FEG
Voltage	5/10/15KV	3-18KV	3-20KV	3-20KV	1-15KV
Detector	BSE+SE	BSE+SE	BSE+SE	BSE+SE	BSE+SE
Navigation CCD	CCD	CCD	CCD+Cabin Camera	CCD+Cabin Camera	CCD+Cabin Camera
Vaccum Time	90s	90s	30s	90s	180s
Vaccum System	Mechanical Pump Molecular Pump	Mechanical Pump Molecular Pump	Mechanical Pump Molecular Pump	Mechanical Pump Molecular Pump Ion Pump	Mechanical Pump Molecular Pump Ion Pump x2
Vaccum	High Vaccum 1x10-1Pa	High Vaccum 1x10-1Pa	High Vaccum 1x10-1Pa	High Vaccum 5x10-4Pa	High Vaccum 5x10-4Pa
Stage	XY Stage, 40x30/40x40mm	XY Stage, 40x30/40x40mm	XY Stage, 60x55mm	XY Stage, 60x55mm	XY Stage, 60x55mm
Stage Precision	-		Position I	Precise 5um	
Working Distance	5-35mm	5-35mm	5-73.4mm	5-73.4mm	5-73.4mm
Max Specimen	80x42x40mm	80x42x40mm	100x78x68.5mm	100x78x68.5mm	100x78x68.5mm
	Tunç	gsten Filament 20 p	ocs/box	Lab6 Filament	Field Emission Lamp
		EDS Oxfo	rd AZtecOne with Xp	oreCompact 30	
-		Low Vacc	cum 1-100Pa Low Vaccum 1-30Pa		um 1-30Pa
	-	Z Axis Module	3 Axis Stage, X 60mm, Y 50mm, Z 25mm		
	-	T Axis Module	3 Axis St	age, X 60mm, Y 50m	m, T ±20°
Optional 5 Axis Stage, X 90mm, Y 50mm, Z 2)mm, Y 50mm, Z 25m	nm, T ±20°, R 360°		
	-	-	Shock-absorbi	ng Platform, For 3 Ax	is, 5 Axis Stage
	-	Deceleration Mode 1-10KV To Watch Non-conduct Samples, Only For B			oles, Only For BSE
1					



Stake Out, Evacuate And Turn On High Pressure.

810	NOTAR .	ticking .	Auto	1	
- Martin	-				
		10 Eky			
	and had had	N 1988	ortini EN		
2474		1 B pA			
1712.0	A CONTRACTOR	- Tele	(Selected		
0.03					
					ontia.
		<u>~</u>		- Comment	
				an 18	
				NA	
				And the second	
					1.1
	100 P m	May ACCOM THURS	247	C I	

Image Display Configuration And Adjustment

leviter.				
84	ASSAE	HIRES	WORK .	
放 中间(图		2652		
19512	88	50072 0	A	
15355 No. 1		ERITS OF		
		BRIEC CRIP	vite ·	
	A SHARE SHORE	TO	62 64 538 258	
20000 2000	12 120000 M	1V#C 010	WTO D	
		~		BASH BAL
		~		
				1 1 1 1 1 1 1 1 1 1 1 1 1 1 1 1 1 1 1
				N
				×
				m =====
	DEV152.0 # #		Def	\sim
-		100 U. J. J	RIA _	

BSE Advanced Configuration

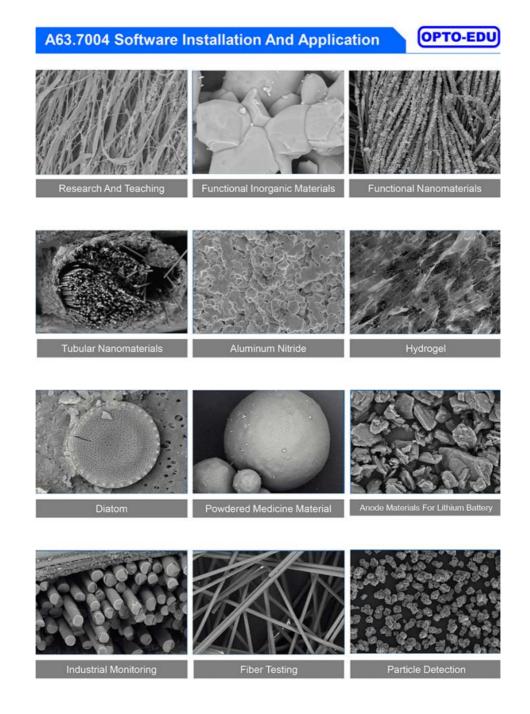


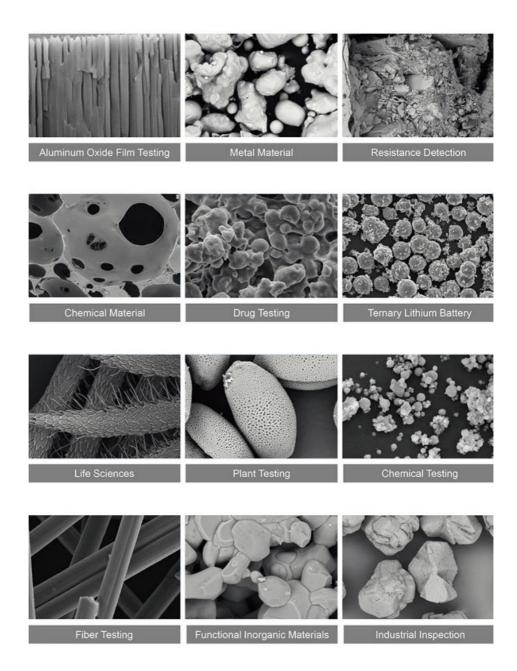
Lens configuration

84 AUXA2	REPORT	WORD	
3045		保設	
x1	100 A	•	
x2	8		
¥1	те —		
¥2	D		
1000 100 H200中。			
1000 IN (ILLANY)			
	~		AN ALEZ
			-
			M
			151.R 4

▶ Turn Off The High Pressure, Vent The Vacuum.

84	AREA	HARRIN	8	Point		
500 ACC	Any Niky They	10. <mark>B</mark> kV	t-sa.	- Destaction		
and a		Au	-	-		1
0.03		v	Valuers	Selected.		
1E9	e i	_				
		~			2	An nckil
						ו
					-	
					-	<u>na —• </u>
					-	
						(10000 (10000) (10000) (
					0	
	100 # m	Mag ACC,997	100,700 Det		es	



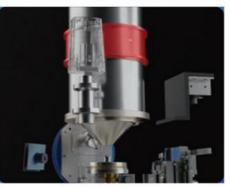


A63.7004 Accessories

OPTO-EDU



Optional 5-axis Center Sample Stage



Sample change time 30s



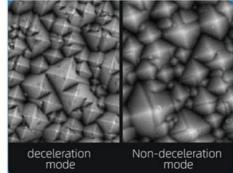
Addition of a camera inside the sample compartment for real-time observation of the sample compartment



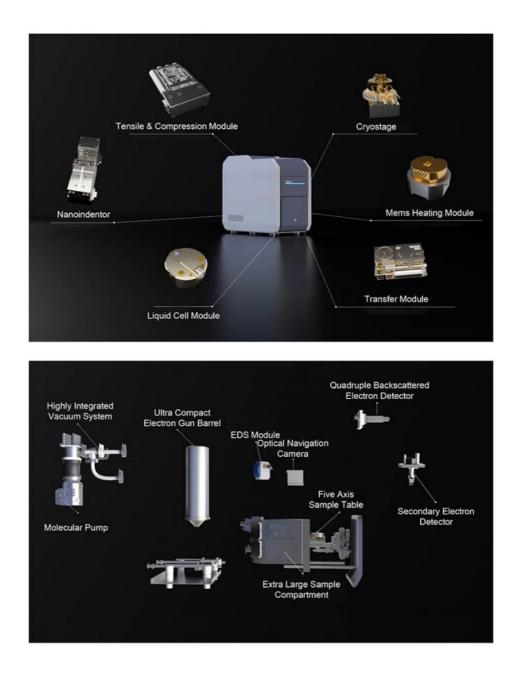
The gun head always maintains 5*10'Pa vacuum, which greatly improves the service life of tungsten filament, and LaBó filament is optional

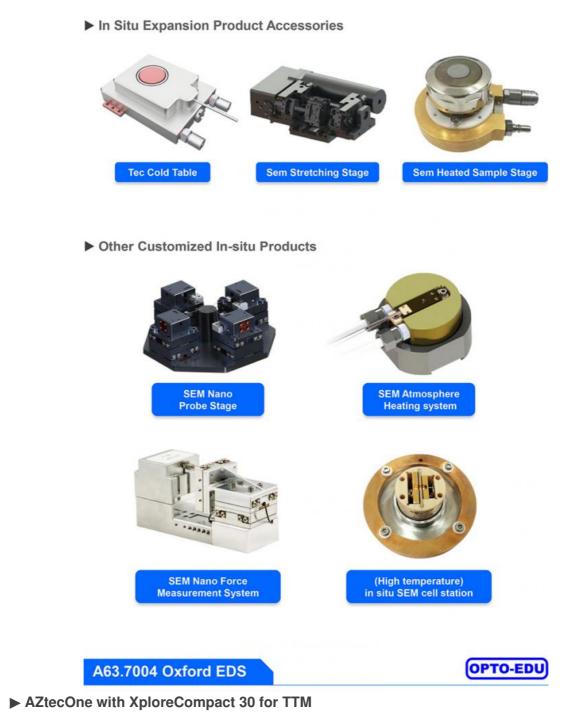


Extra large sample compartment,L185mm*w176mm*H125mm



10kv sample Table High Voltage Reduction Option

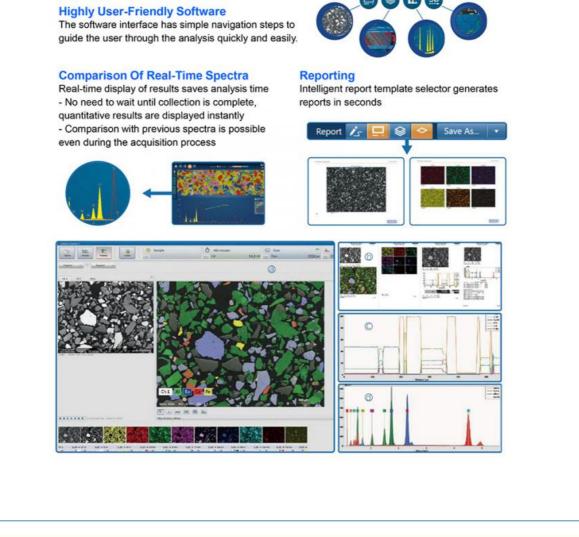




System Conventional Eds Analysis

The system provides qualitative and quantitative analysis of different materials, analyzing elements ranging from B(5) to cf (98).in addition to individual point scans of the sample surface, powerful line scans and elemental spectral scans are also available. combined with a customized detector, analysis and reporting can be done in seconds.

Effective Crystal Area	30mm2	Resolution (Of A Photo)	Mn Ka <129eV @50,000cps
Elemental Detection Range	B (5) to cf (98)	Maximum Input Count Rate	>1,000,000 cps



	9.	Opto-Edu (Beijing) Co	., Ltd.
O	0086 13911110627	sale@optoedu.com	Cnoec.com
F	-1501 Wanda Plaza, No.	18 Shijingshan Road, Beijing	100043, China